

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul A. Farrar

Title: METHOD OF CLEANING SEMICONDUCTOR SURFACES

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Examiner: Nicole Blan
Customer No.: 73115

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Notice of Allowance Date: August 31, 2009

Mail Stop Issue Fee

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

We are transmitting herewith the following:

- ☒ Authorization to charge Deposit 19-0743 in the amount of \$1510.00 to cover the Large Entity Issue Fee Payment.
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- ☒ Supplemental Information Disclosure Statement (2 pages).
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By



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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 30th day of November, 2009.

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